

Appl. No. : 09/654,845 Confirmation No. 6844
Applicant : Jifa Hao, et al.
Filed : September 1, 2000 Art Unit: 2811
Title : POWER SEMICONDUCTOR DEVICE WITH HIGH AVALANCHE CAPABILITY AND PROCESS FOR FORMING SAME
Examiner : Ori Nadav
Docket No. : 87552.99R272 (17732.6323)
Customer No. : 44,331

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir:

Responsive to the November 1, 2006 Office Action, Applicants submit the following Amendment:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.

OIC to enter
O.N. 1/22/07